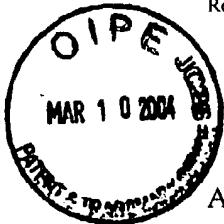


Do not enter

BT

Appl. No. 10/010,548
Amdt. dated March 8, 2004
Reply to Office Action of January 7, 2004



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:	Geun-Young Yeom, et al.) Examiner:
) Tran, Binh X.
SERIAL NO.:	10/010,548)
)
FILED:	November 8, 2001) Art Unit:
) 1765
FOR:	METHOD OF ETCHING)
	SEMICONDUCTOR DEVICE USING)
	NEUTRAL BEAM AND APPARATUS)
	FOR ETCHING THE SAME)

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

Applicants respectfully request entry of the following amendment and remarks contained herein in response to the Office Action mailed January 7, 2004. Applicants respectfully submit that the amendment and remarks contained herein place the instant application in condition for allowance.